

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/750,974	KIM ET AL.
Examiner	Art Unit	
	Kevin M. Picardat	2822

SEARCHED			
Class	Subclass	Date	Examiner
257	40	9/28/2005	KMP
	79		
	98		
	99		
	100		
	103		
438	26		
	29		
	34		
	82		

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
AS	ABOVE	9/30/2005	KMP